

FIG. 1

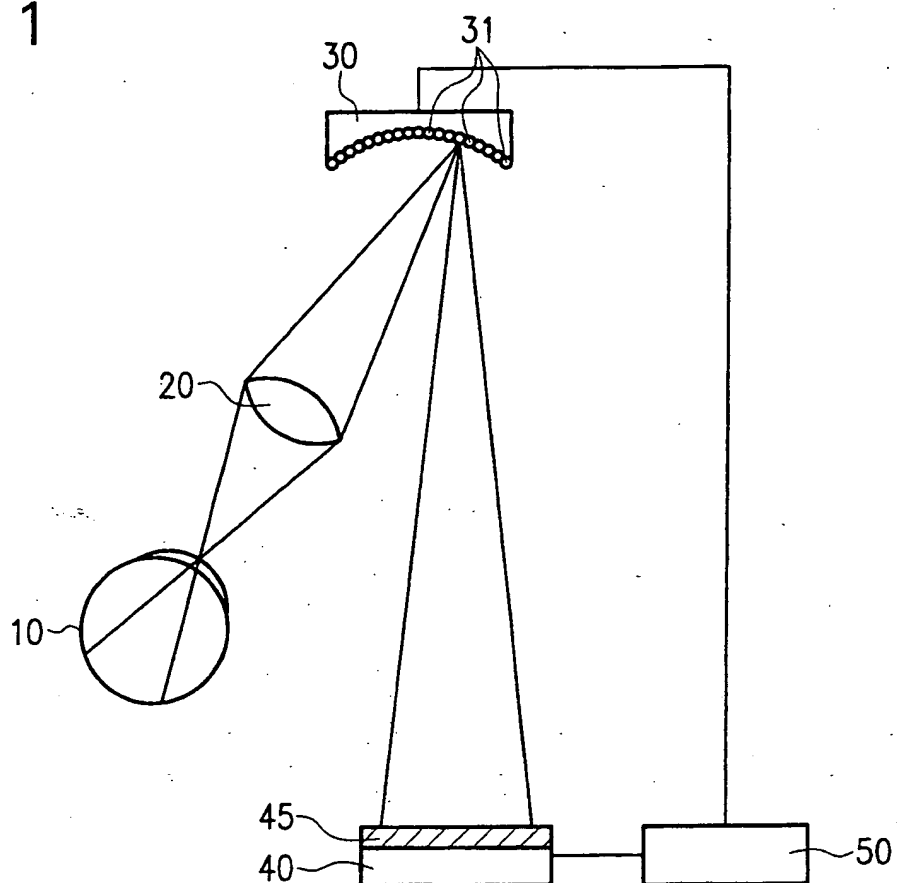


FIG. 2A

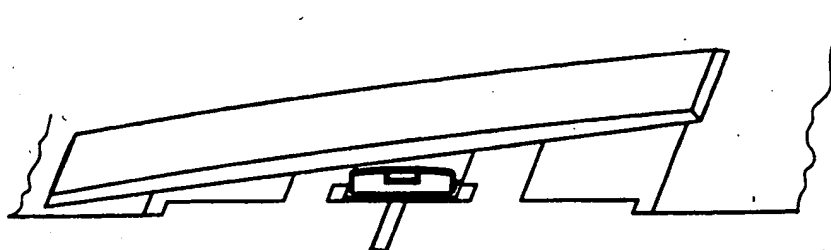


FIG. 2B

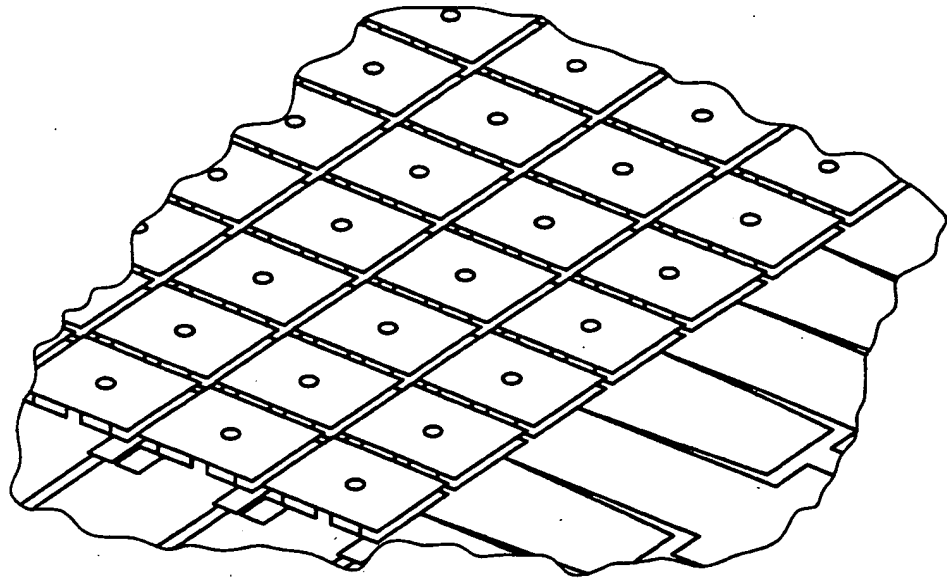
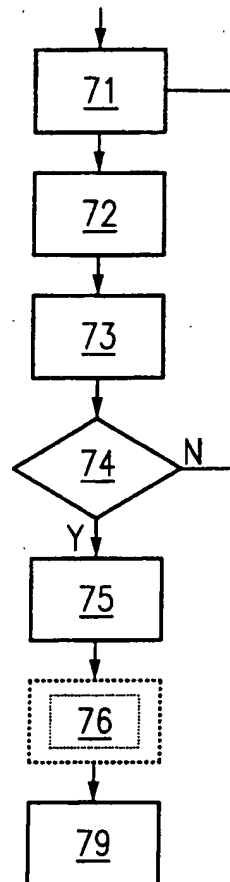


FIG. 3



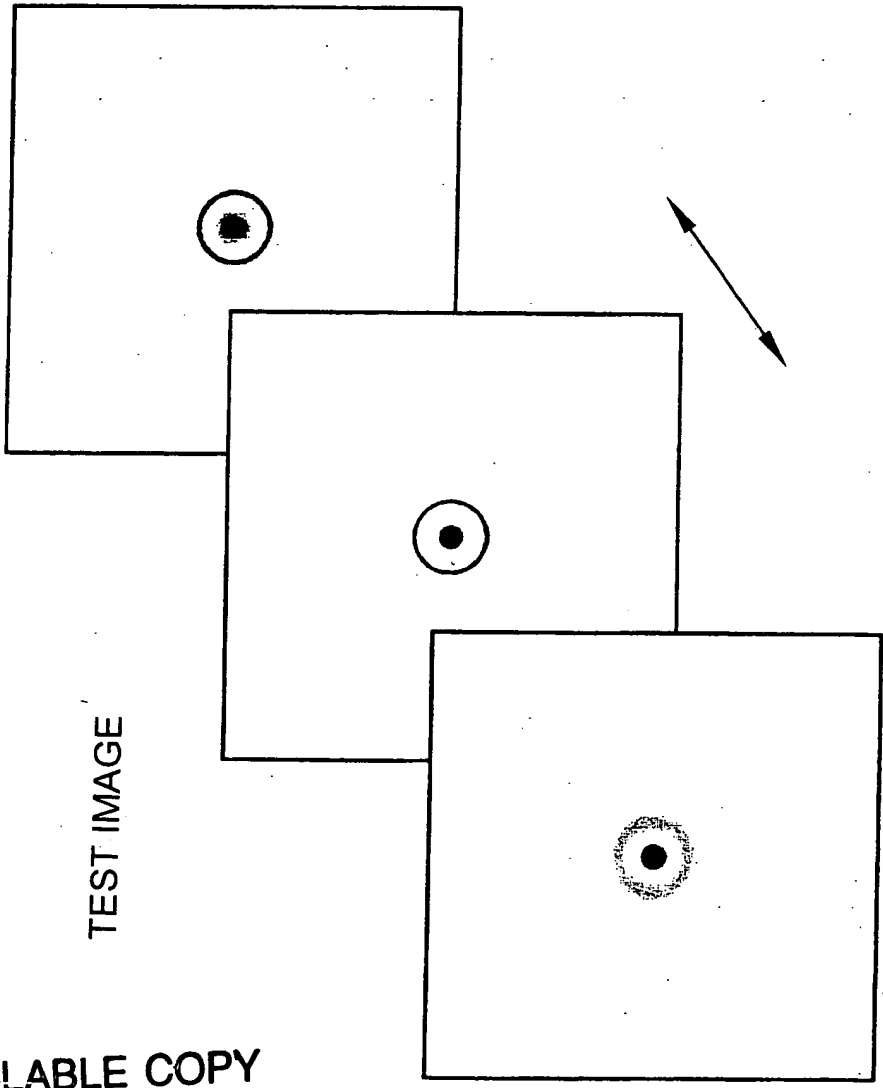
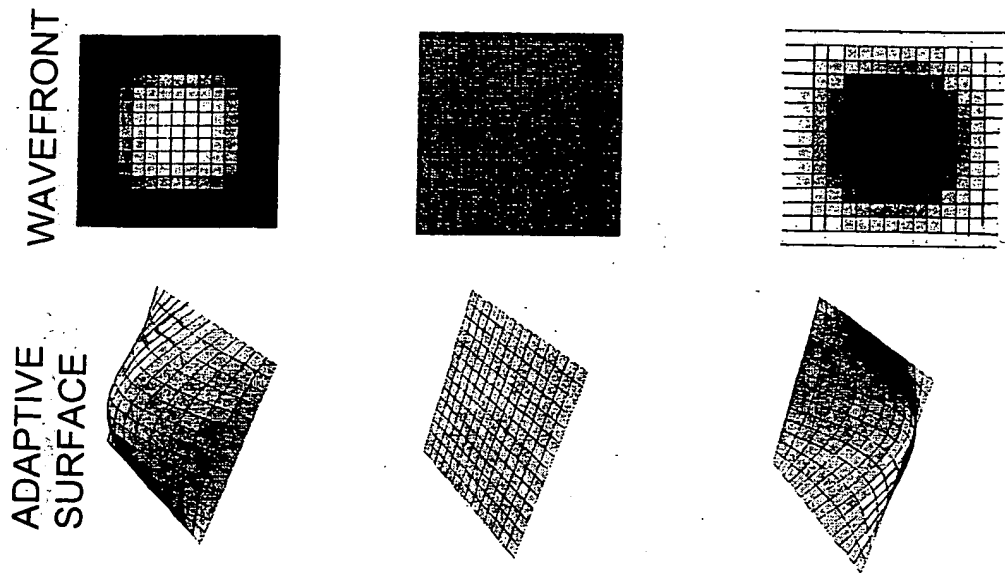


FIG. 4A  
BEST AVAILABLE COPY

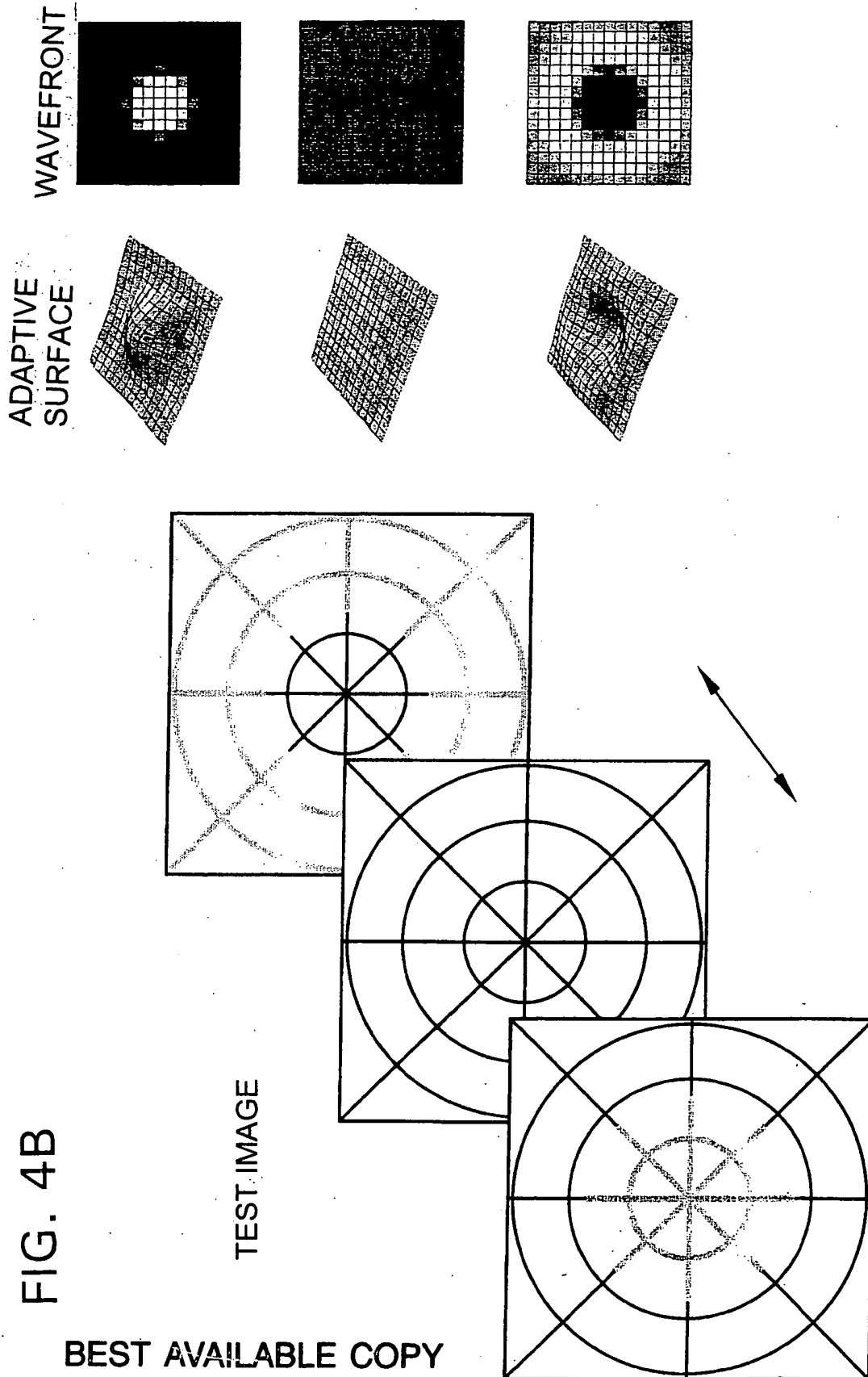


FIG. 4B

BEST AVAILABLE COPY

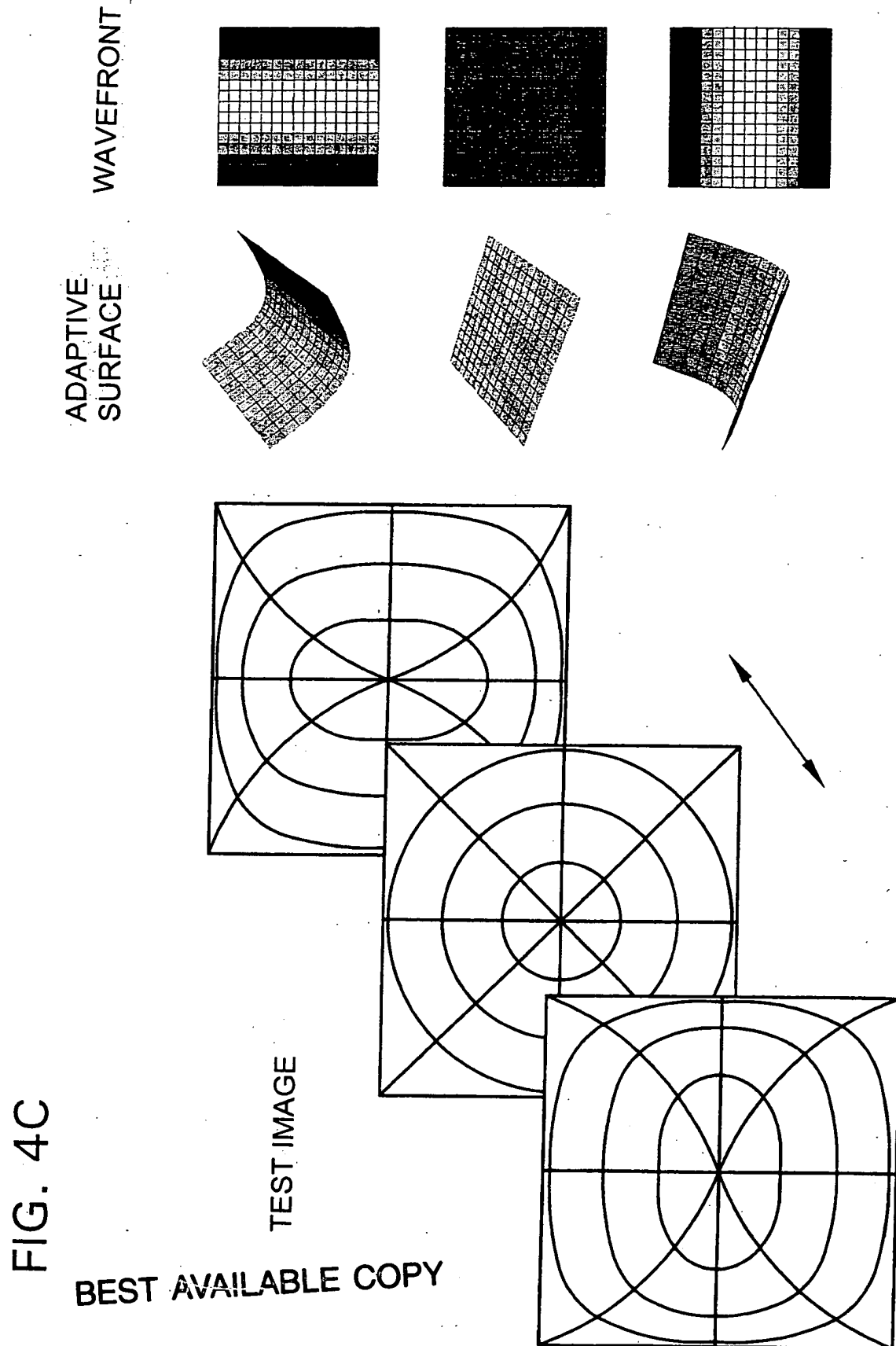


FIG. 5

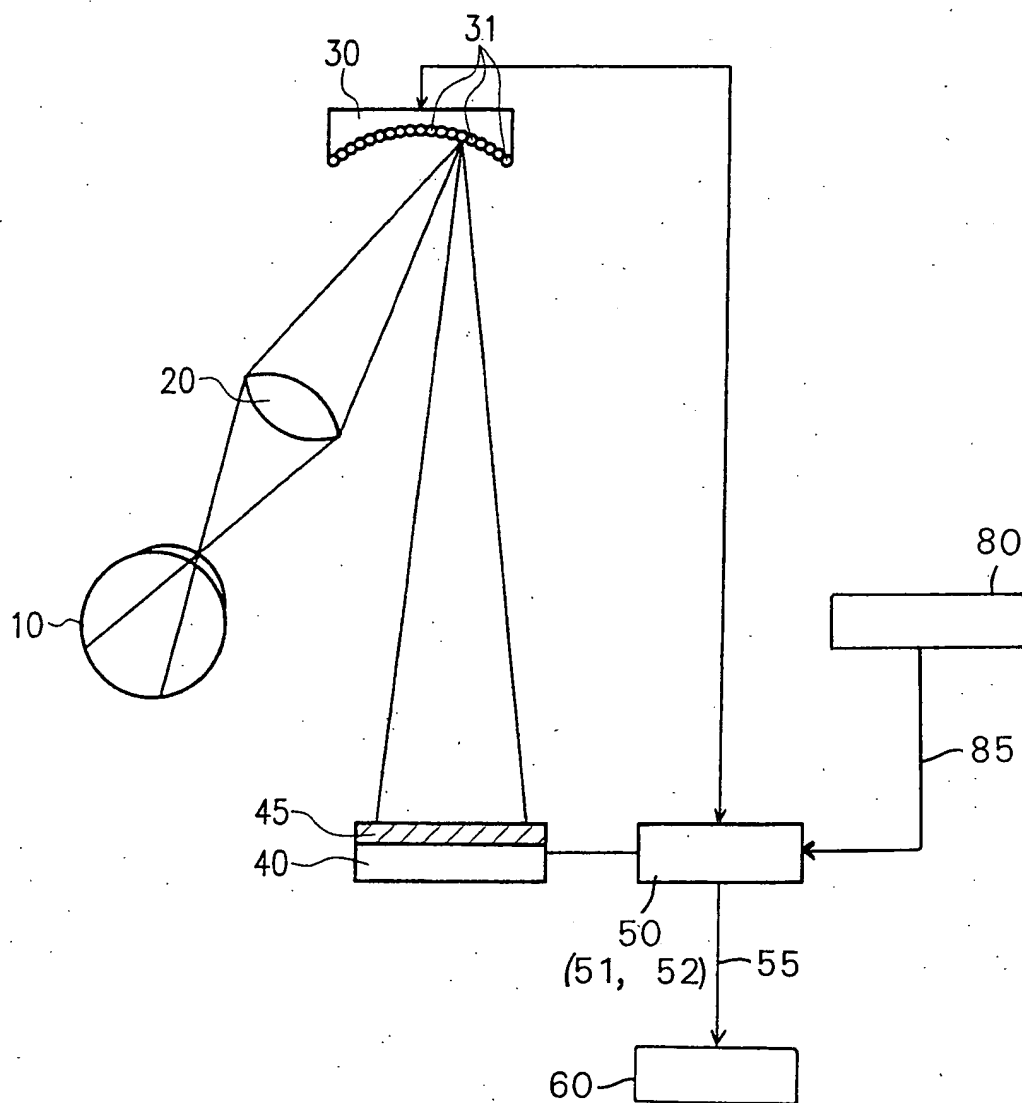


FIG. 6

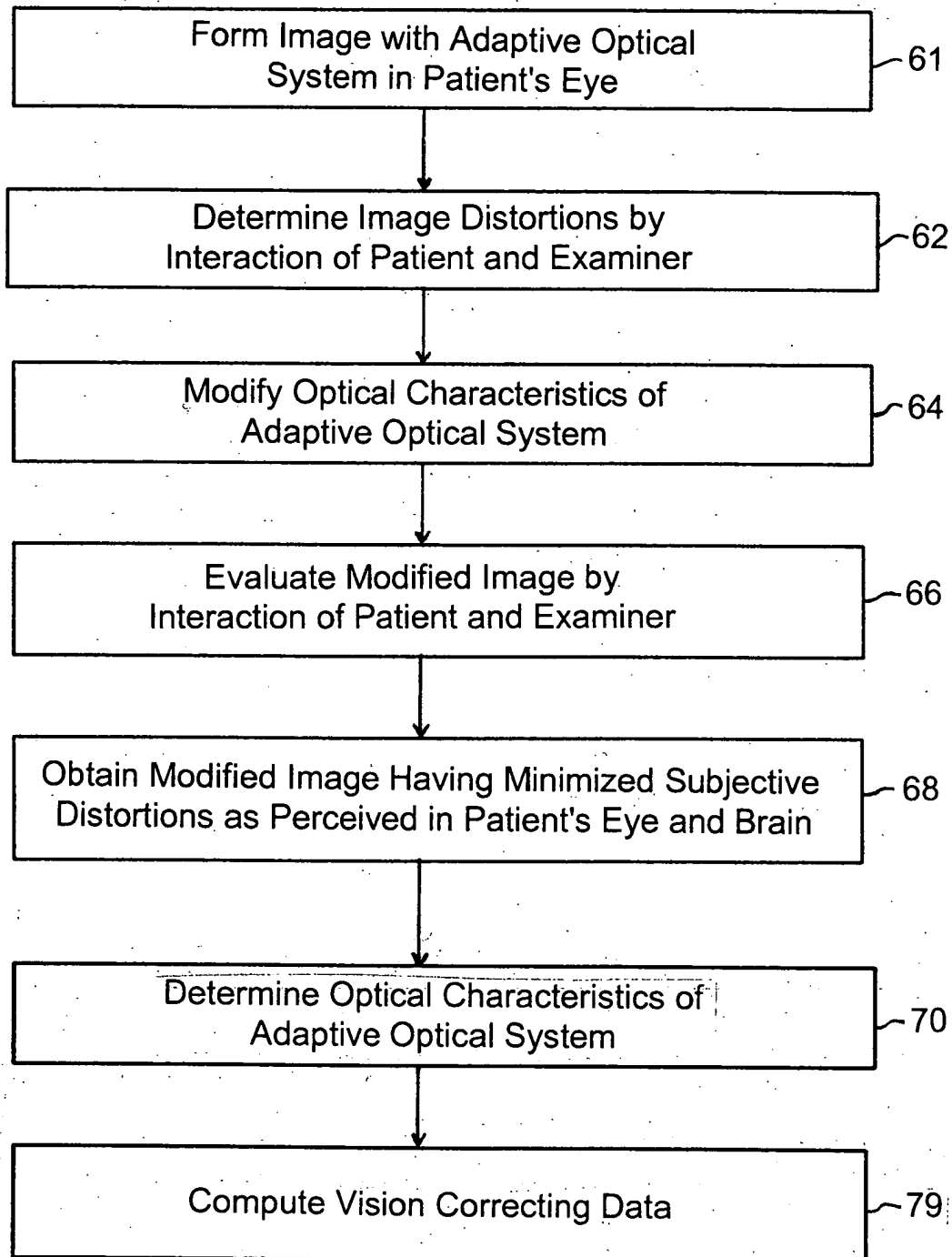


FIG. 7

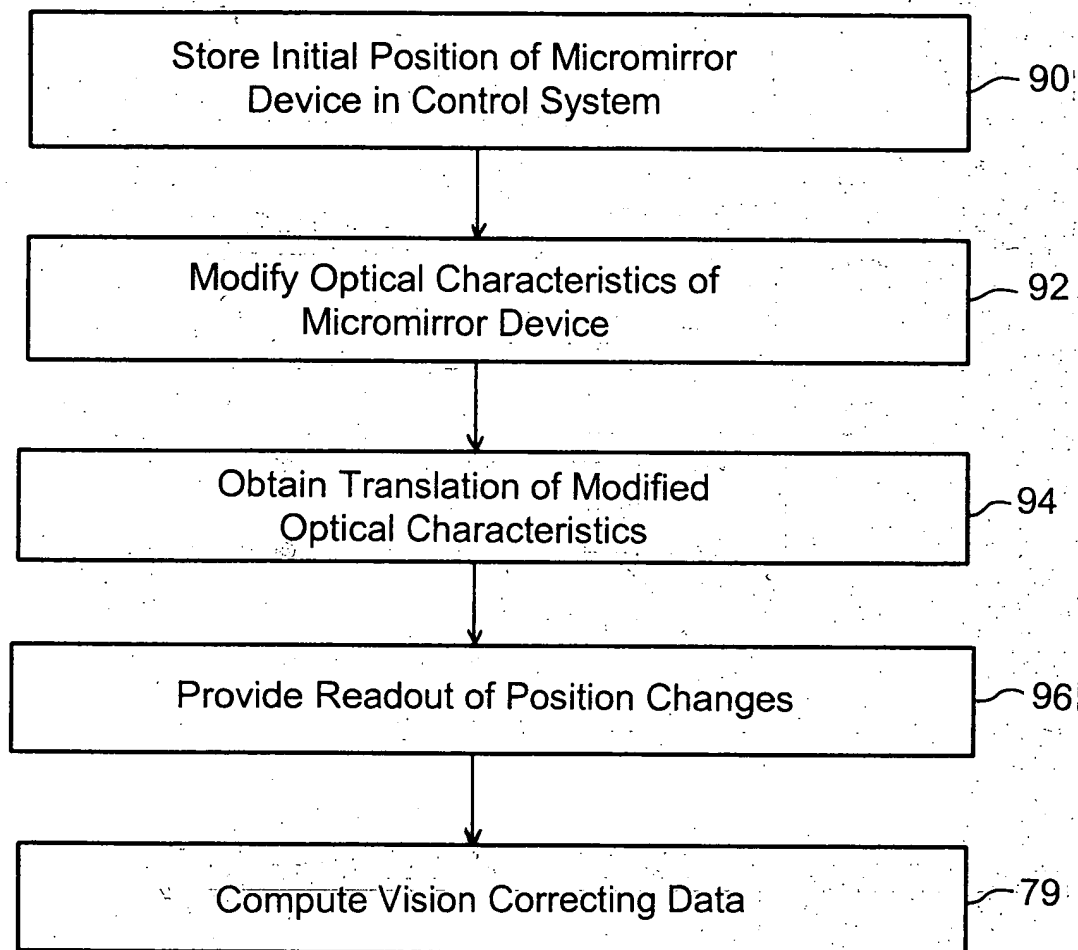




FIG. 8

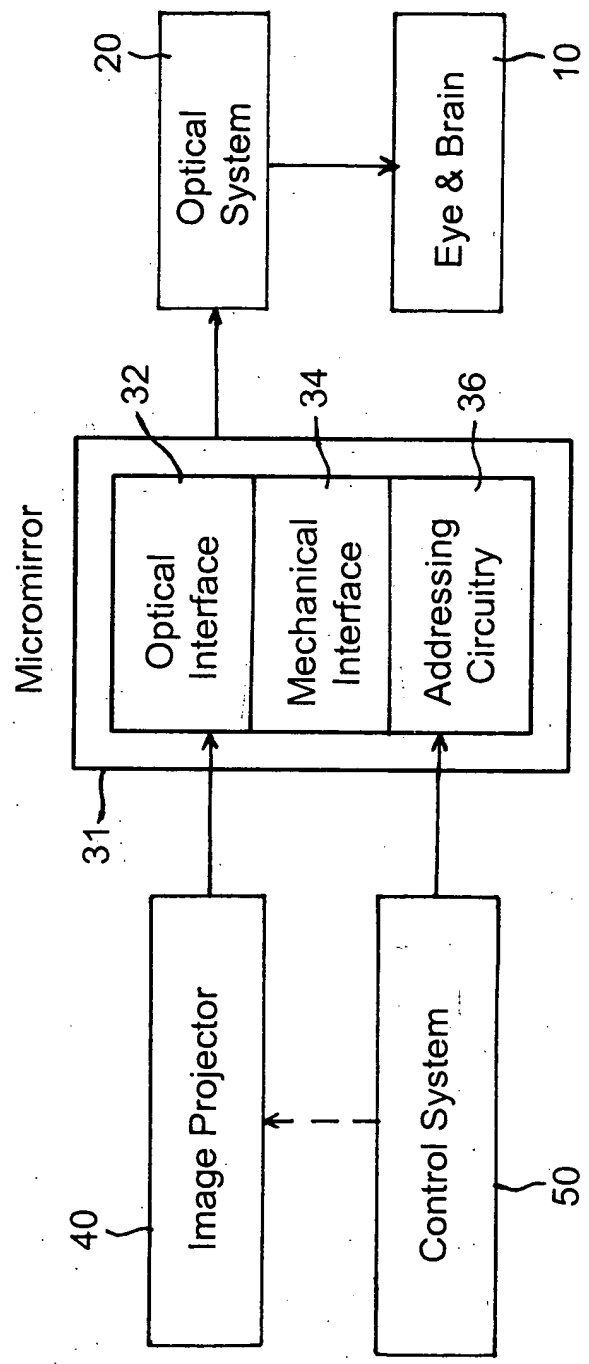


FIG. 9

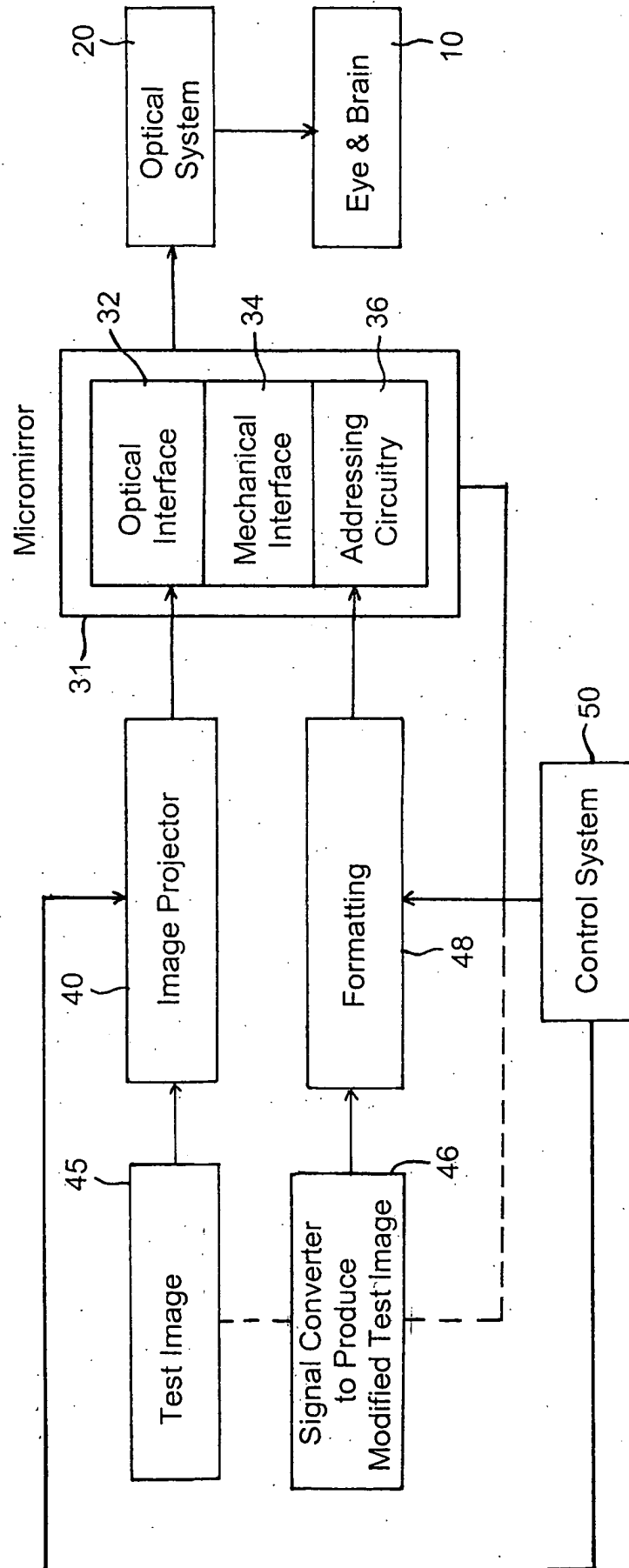


FIG. 10

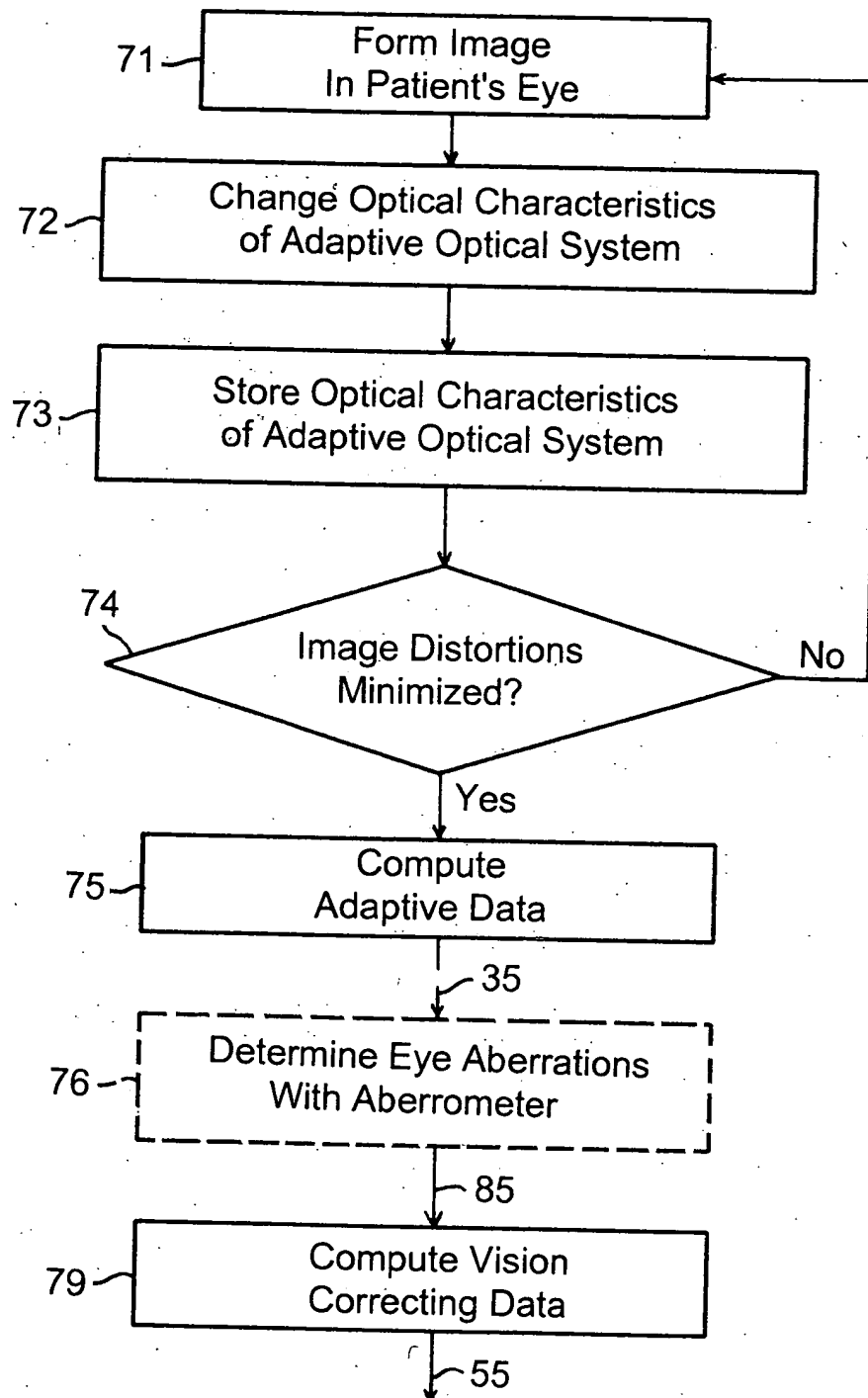


FIG. 10A

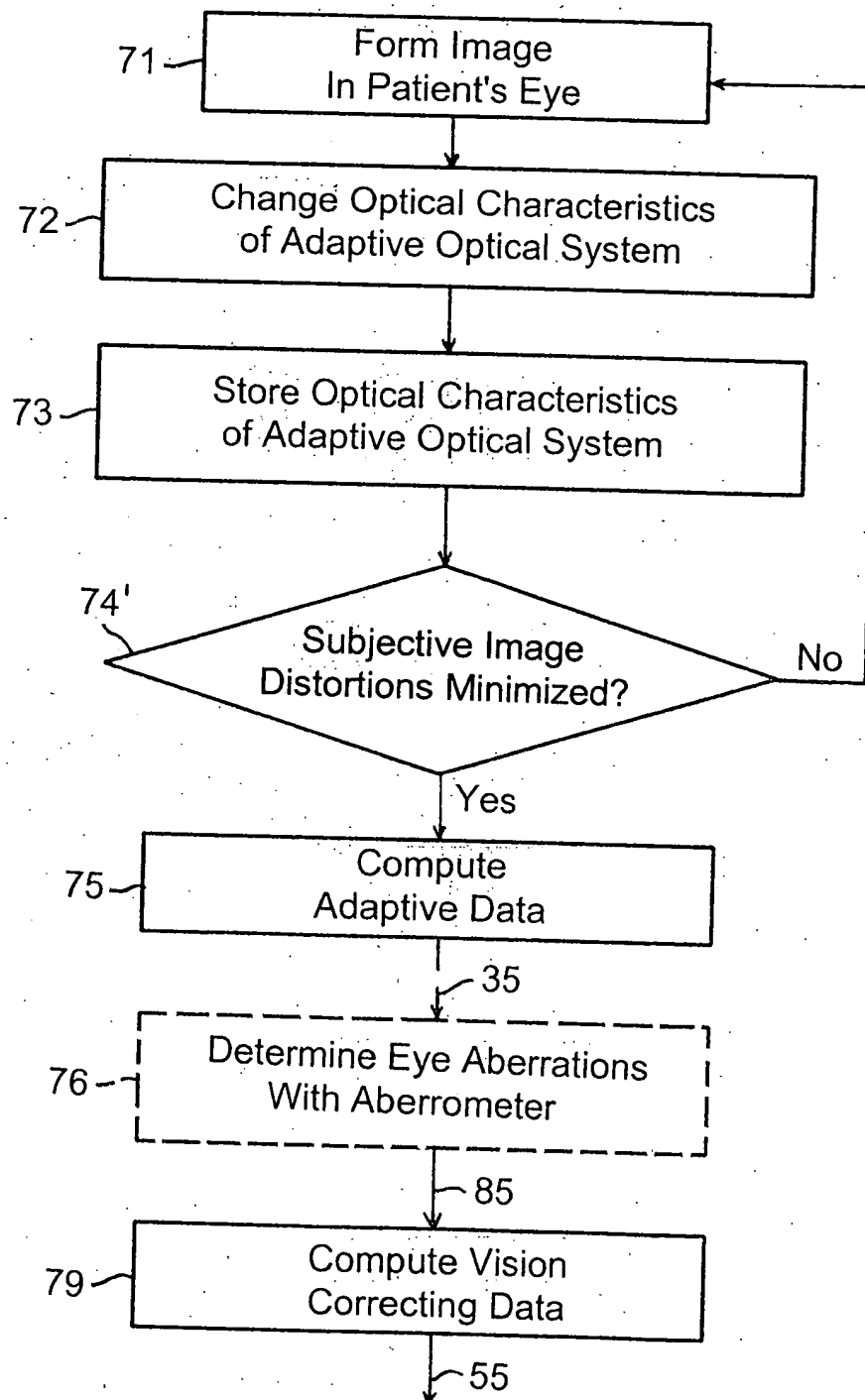
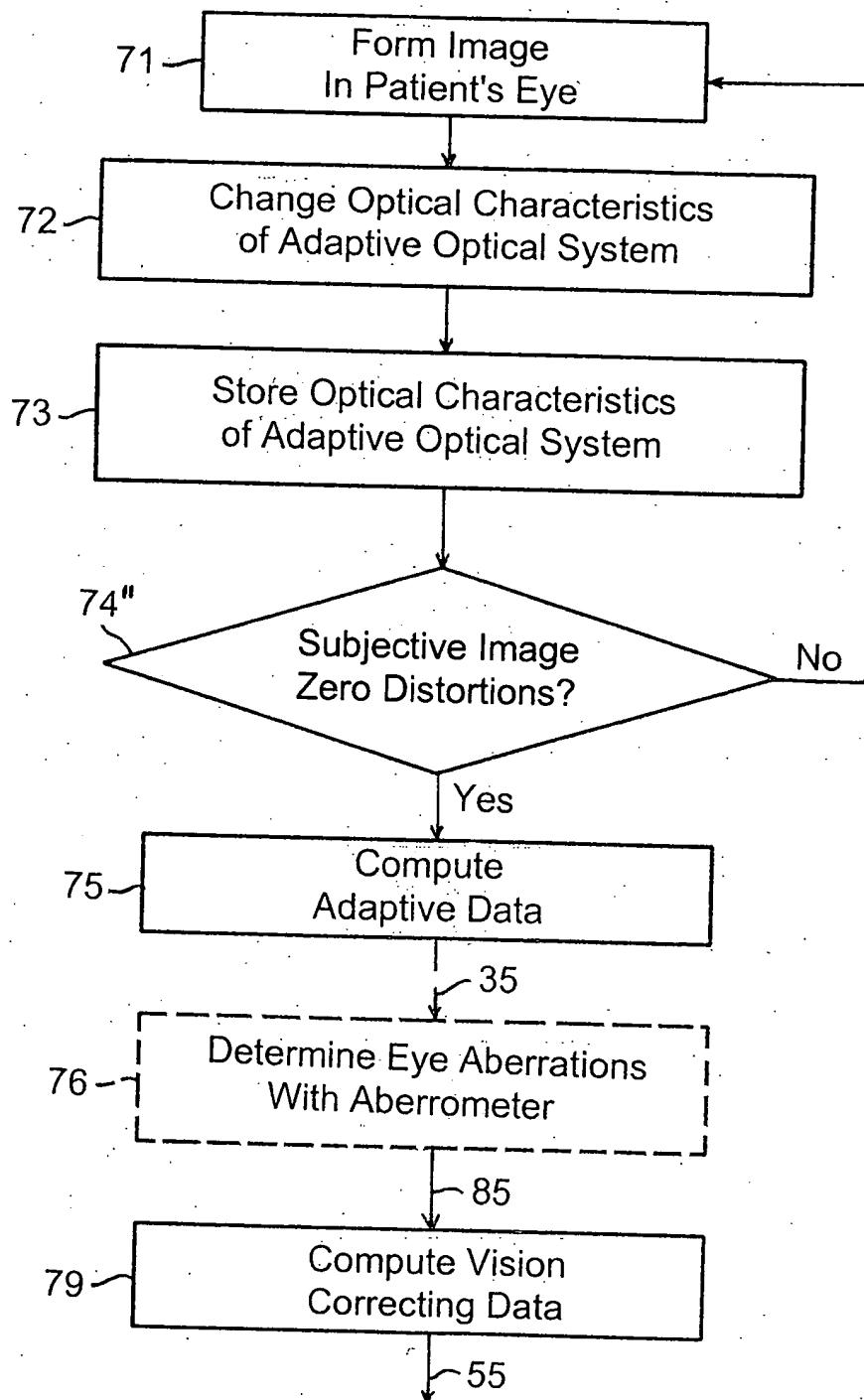


FIG. 10B



MICROMIRROR DEVICE

FIG. 11

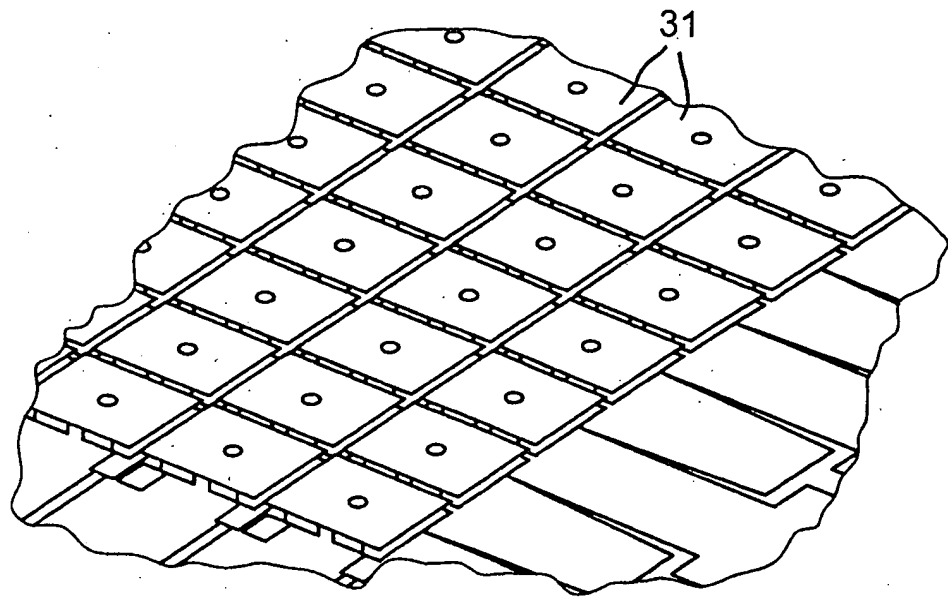
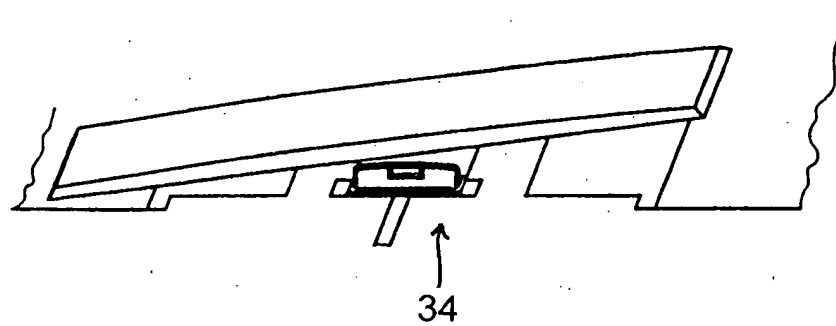


FIG. 12



INTERFACE

ELECTROSTATIC  
PIEZOELECTRIC  
BIMORPH  
ACTUATION